

## PATENT ASSIGNMENT COVER SHEET

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<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT
<b>NATURE OF CONVEYANCE:</b>	ASSIGNMENT
<b>CONVEYING PARTY DATA</b>	
<b>Name</b>	<b>Execution Date</b>
RESEARCH AND DEVELOPMENT CENTER, SHANGHAI INSTITUTE OF CERAMICS	12/21/2020
SHANGHAI INSTITUTE OF CERAMICS, CHINESE ACADEMY OF SCIENCES	12/21/2020
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<b>State/Country:</b>	CHINA
<b>PROPERTY NUMBERS Total: 1</b>	
<b>Property Type</b>	<b>Number</b>
Patent Number:	9228275
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<b>SIGNATURE:</b>	/SIBYL YU/
<b>DATE SIGNED:</b>	12/25/2020
<b>Total Attachments: 3</b>	
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## Form of Recordable Patent Assignment and Reservation

WHEREAS, in consideration of One Dollar(\$1.00) and other goods and valuable considerations, the receipt of which is hereby acknowledged, and subject to the reservations stated in the Patent Assignment Agreement

RESEARCH AND DEVELOPMENT CENTER, SHANGHAI INSTITUTE OF CERAMICS, a corporation organized and existing under the laws of CHINA,

SHANGHAI INSTITUTE OF CERAMICS, CHINESE ACADEMY OF SCIENCES, a corporation organized and existing under the laws of CHINA,

(hereinafter "ASSIGNOR(S)")

HEREBY grant(s) and assign(s) to

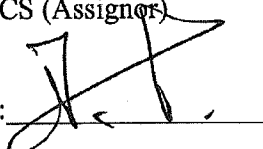
Anhui Weixin Changjiang Semiconductor Material Co., Ltd., a corporation organized and existing under the laws of CHINA,

(hereinafter "ASSIGNEE(S)")

all of the ASSIGNOR(S)'s rights, title and interest in and to the United States Letters Patent(s) and patent application(s) identified in Exhibit A attached hereto, (hereinafter, collectively, "ASSIGNED PATENT(S)"), to have and to hold the same, unto ASSIGNEE(S) for his/their own use and enjoyment and for the use and enjoyment of his/their successors and assigns, including all damages for infringement of any of the ASSIGNED PATENT(S) and the sole right to sue therefore under such ASSIGNED PATENT(S), for the full term(s) of all such ASSIGNED PATENT(S), subject to all rights granted under the ASSIGNED PATENT(S) to third parties by ASSIGNOR(S) prior to the effective date of the said Patent Assignment Agreement.

ASSIGNOR(S) hereby reserve(s) and retain(s), for the benefit of himself/themselves and his/their subsidiaries and their successors and assigns, the rights and licenses set forth in the Patent Assignment

RESEARCH AND DEVELOPMENT  
CENTER, SHANGHAI INSTITUTE OF  
CERAMICS (Assignor)

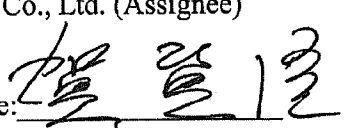
Signature: 

Name: Dong WANG

Title: Director

Date: 2020.12.21

Anhui Weixin Changjiang Semiconductor  
Material Co., Ltd. (Assignee)

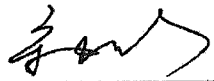
Signature: 

Name: Xianhan HE

Title: General manager

Date: 2020.12.21

SHANGHAI INSTITUTE OF  
CERAMICS, CHINESE ACADEMY OF  
SCIENCES (Assignor)

Signature: \_\_\_\_\_

Name: Lixin SONG

Title: Director

Date: 2020.12.21

**Exhibit A****United States Letters Patent(s)**

Serial No.	Patent No.	Issue Date	Assignor		Assignee	
			Name	Interest(%)	Name	Interest(%)
1	9,228,275	2016/01/05	RESEARCH AND DEVELOPMENT CENTER, SHANGHAI INSTITUTE OF CERAMICS	50%	Anhui Weixin Changjiang Semiconductor Material Co., Ltd.	100%
			SHANGHAI INSTITUTE OF CERAMICS, CHINESE ACADEMY OF SCIENCES	50%		

**End of Exhibit A**